

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Z. E. Cabrera
Keiji YOSHIMURA	)	
	:	Group Art Unit: 2125
Application No.: 09/964,648	)	
	:	Confirmation No.: 1952
Filed: September 28, 2001	)	
	:	
For: EXPOSURE APPARATUS, SEMICONDUCTOR	)	October 27, 2006
DEVICE MANUFACTURING METHOD,	:	
EXPOSURE APPARATUS MAINTENANCE	)	
METHOD AND SEMICONDUCTOR	:	
MANUFACTURING FACTORY	)	

**Mail Stop RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application as follows: